

41
Our Ref.: 3008-0034
File No.: 521.41463X00
Client Ref.: PHCF-01103

PATENT

2811



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Oka, et al. :
: Art Unit: 2811
Application S/N 09/925,626 :
: Examiner: Shouxiang Hu
Filed: August 10, 2001 :
Confirmation No. 2918 :
Customer No. 020457 :

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,
CRYSTALLINE SILICON FILM PHOTOVOLTAIC DEVICE, AND PROCESS
FOR PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR
DEVICE

TRANSMITTAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 17, 2004

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☐ No additional fee is required.

☒ Also attached: Credit Card Payment Form

The fee (if applicable) has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	34	20	14	x \$18 =	\$252.00
Independent Claims	5	4	1	x \$86 =	\$86.00
TOTAL FEE DUE					\$338.00

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- [X] A Credit Card Payment form in the amount of \$338.00 is attached
- [X] Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment, to Deposit Account No. 01-2135, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully Submitted,

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SWC/slk

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 17, 2004

Sir:

In response to the non-final Official Action dated December 17, 2003, the time for response to which is up to and including March 17, 2004, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims follow.

Remarks are included following the amendments.

03/18/2004 JBALINAH 00000103 09925626

01 FC:1201 86.00 OP
02 FC:1202 252.00 OP